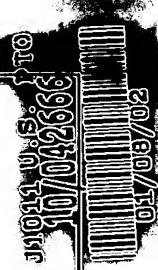


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|---|---|
| In re Application of: Han, et al. | Group Art Unit: Unknown |
| Serial No: N/A | Examiner: Unknown |
| Filed: Herewith | Attorney Docket No: 003330 USA/ETCH/METAL/JB |
| For: PROCESS CHAMBER HAVING COMPONENT WITH YTTRIUM-ALUMINUM COATING | December 21, 2001 San Francisco, California |



INFORMATION DISCLOSURE STATEMENT

Box Patent Application
Commissioner for Patents
Washington, D.C. 20231

Dear Sir/Madam:

Attached hereto are PTO-1449 forms listing documents believed relevant to the subject application. It is respectfully requested that these documents be considered by the Examiner and initialed copies of the PTO-1449 forms be returned to the undersigned.

It is believed that this disclosure complies with the requirements of 37 C.F.R. §§ 1.56, 1.97 and 1.98, and the Manual of Patent Examining Procedures § 707.05(b). If for some reason the Examiner considers otherwise, it is respectfully requested that the undersigned be called so that any deficiencies can be remedied.

A copy of each document is enclosed.

Some of the documents may have markings thereon. No significance is meant to be attached to the markings.

With regard to any translations which may be provided herewith, the undersigned does not know how and who made the translations. Therefore, no representation is being made as to the accuracy of any translation.

These documents are not necessarily analogous.

Respectfully submitted,

JANAH & ASSOCIATES
A PROFESSIONAL CORPORATION

Date: December 21, 2001

By: _____


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Encl.